



#9/AmA
Attorney Docket No.: 0190116
6-303

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Mann

Serial No.: 09/935,231

Filed: August 22, 2001

For: **Semiconductor Device for Isolating a
Photodiode to Reduce Junction Leakage and
Method of Formation**

Art Unit: 2815

Examiner: Wojciechowicz, E. J.

RECEIVED
MAY 30 2003
TECHNOLOGY CENTER 2800

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Office Action dated January 29, 2003 in the above-referenced patent application. Please enter and consider the following remarks.